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PATENT

Reply under 37 CFR § 1.116
Expedited Procedure
Group Art Unit 2822

**IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE**

Applicants: MUN, Young Hee et al.

Serial No.: 10/699,438

Filed: October 31, 2003

Title: SILICON WAFER AND
METHOD OF FABRICATING
THE SAME

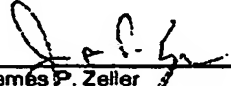
Group Art Unit: 2822

Examiner: GUERRERO, Maria F.

Attorney Docket No.: 29936/39510

I hereby certify that this correspondence is
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February 13, 2006


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*Entered
w/ RCE
3.16.06*

AMENDMENT "B" AFTER FINAL REJECTION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

In response to the final official action dated December 14, 2005, please amend the
above-identified patent application as set forth herein.

Amendments to the claims begin on page 2 of this paper.

Remarks begin on page 7 of this paper.

*IMP
3.24.06*